



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: VON AMMON ET AL -9 EXAMINER: J. MONDT
SERIAL NO.: 09/813,240 GROUP: 2826
FILED: MARCH 20, 2001
TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND METHOD
FOR PRODUCING THE SEMICONDUCTOR WAFER

AMENDMENT IN RESPONSE TO NON FINAL OFFICE ACTION

Mail Stop Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Non-Final Office Action dated November 20, 2003, with the time for reply having been extended for three (3) months from February 20, 2004 until MAY 20, 2004, please amend the above-identified patent application as follows:

Amendments to the Specification begin on Page 2 of this document.

Amendments to the Claims begin on Page 4 of this document.

Remarks/Arguments begin on page 6 of this document.